

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Shunpei YAMAZAKI et al.

Serial No. 09/295,607

Filed: April 22, 1999

For: SEMICONDUCTOR DEVICE HAVING

ALUMINUM NITRIDE FILM



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) Group Art Unit: 2811

) Examiner: S. Loke

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) Date: September 5, 2000

#17
Prior
Art
FJONES
9-19-00

INFORMATION DISCLOSURE STATEMENT

AND CORRECTION OF PRIOR

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents

Washington, D.C. 20231

Sir:

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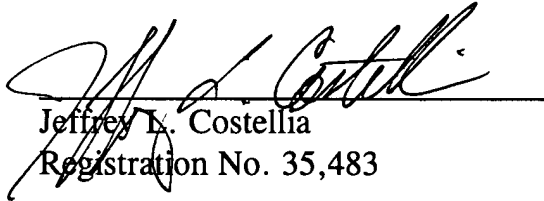
In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the reference(s) listed on the attached Form PTO-1449 be made of record in the above-identified application.

Supplemental to the Information Disclosure Statement filed May 30, 2000, Applicants wish to correct a typographical error to the Form PTO-1449. Upon reviewing the IDS, Applicants note that Japanese Patent No. 61-25663 should actually read 61-256663. Applicants submit herewith a corrected Form PTO-1449 for the Examiner's consideration.

The Commissioner is hereby authorized to charge fees under 37 C.F.R. §1.16, 1.17, 1.20(a), 1.20(b), 1.20(c), and 1.20(d) (except the Issue Fee) which may be required now or hereafter, or credit any overpayment to Deposit Account No. 19-2380.

A copy of the references cited herein is submitted herewith in accordance with 37 C.F.R. 1.98(a).

Respectfully submitted,



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